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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Takahiro HORIGUCHI, et al.

SERIAL NUMBER: 09/855,493

GROUP: 1763

FILED: May 16, 2001

EXAMINER: KACKAR, RAM N

FOR: SINGLE-SUBSTRATE-PROCESSING APPARATUS FOR SEMICONDUCTOR
PROCESS

REQUEST TO CORRECT TITLE OF INVENTION

MAIL STOP ISSUE FEE
COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

SIR:

In the matter of the above-identified application for patent, we hereby request
correction of your records to reflect the correct title of the invention. The title of the
invention should read as follows: SINGLE-SUBSTRATE-PROCESSING APPARATUS
FOR SEMICONDUCTOR **PROCESS**.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

A handwritten signature in cursive script, appearing to read "Marvin J. Spivak".

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